



UNLOCKING EFFICIENCY, STRATEGIES FOR ENHANCED PIC TESTING PERFORMANCE

Sophie Lange, Business Development Engineer

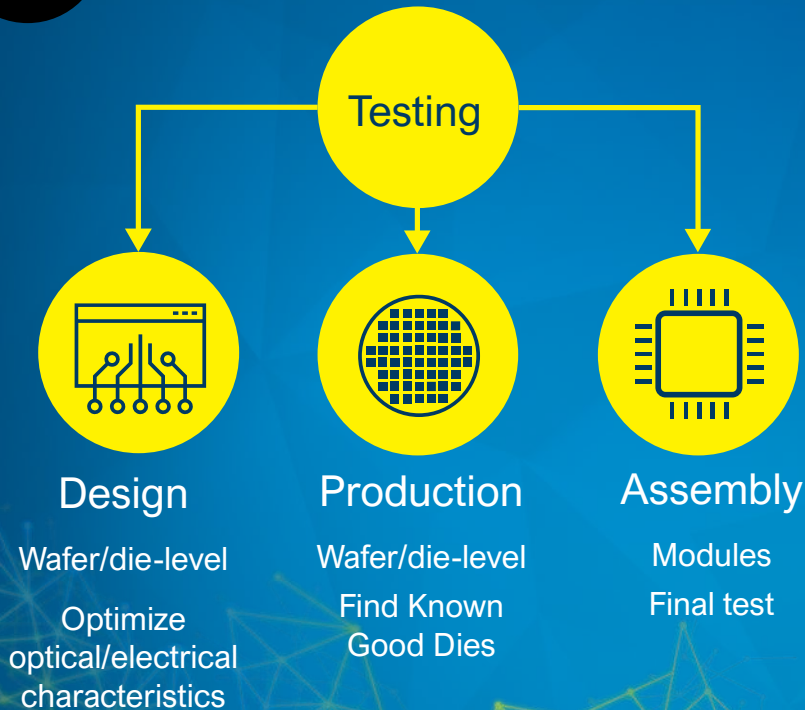
EPIC Technology Meeting on Photonic Integration
and Packaging at Fraunhofer IZM

EXFO

Why testing is important process in PIC technology?

1

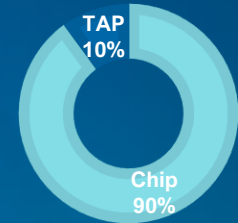
Testing is important from wafer to die to finished component



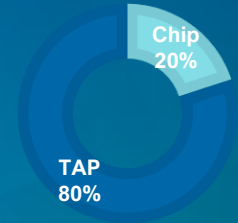
2

Testing, Assembly & Packaging (TAP) has high cost compared to electronics testing so identifying **known good dies** is essential

Electronics
Chip
\$



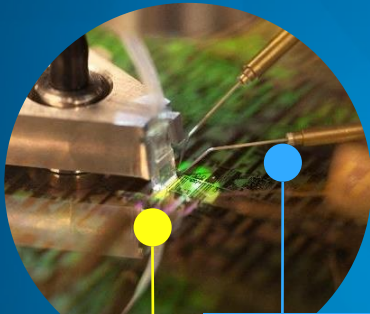
Photonics
Chip
\$\$\$



Testing process must be **repeatable, scalable and traceable** and leverage **automation and flexibility**

The 3 Steps of Testing

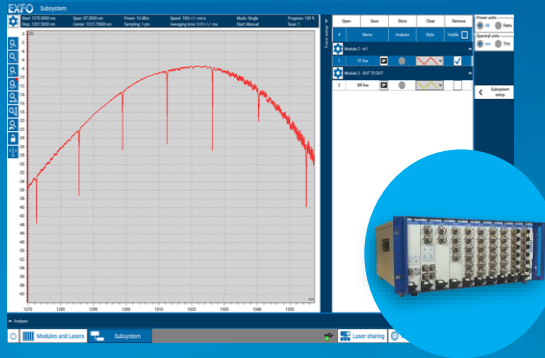
1 Optical Fiber Coupling & Electrical Probing



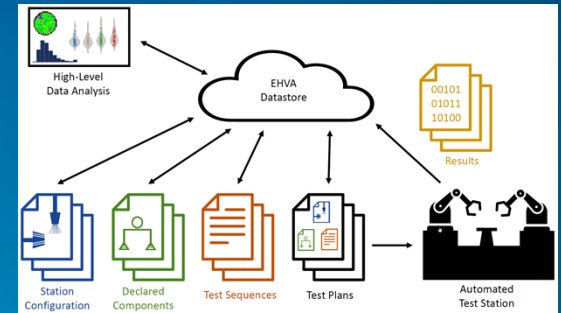
Optical fiber array

Electrical probe

2 Optical & Electrical Testing



3 Data Management and Analysis





PIC Testing Bottlenecks

1. Time to align fiber

Manual processes

2. On-chip navigation

Moving next component to the probes

3. Pick and place

Loading dies one-by-one onto the probe station

4. Test time

Time to control and run test instruments

5. Disconnected interfaces

Motion control, test instruments, data handling on multiple platforms from different vendors

6. Data handling

traceability throughout process chain, completeness of data including all parameters, experimental conditions etc.

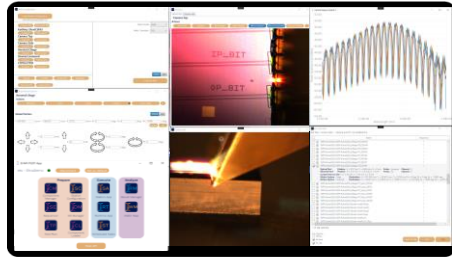
6. No standardization

Variety of components require flexible test setups

Enhancing Testing Efficiency

Full automation of motion control, instrument drivers and database from single interface

Test orchestrated from single software interface



Big data



Data analysis



Artificial intelligence



Business intelligence



Station configuration

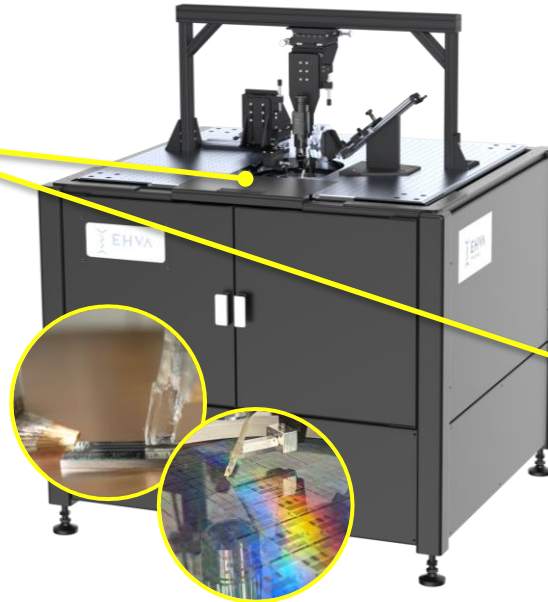
Component

Sequence

Test Plan

Results

Flexible single-die, multi-die or wafer tester



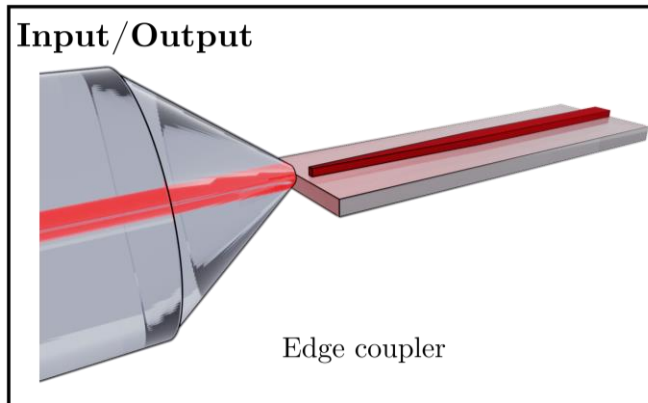
Instrumentation for full characterization



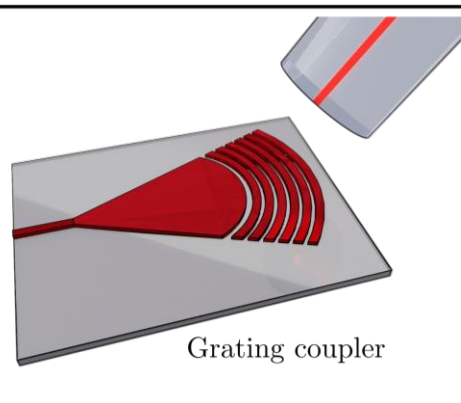
3rd party instruments

Optical Fiber Coupling: Surface vs. Edge

Edge coupling



Surface coupling



Pros: high coupling efficiency, broad bandwidth, polarization independent

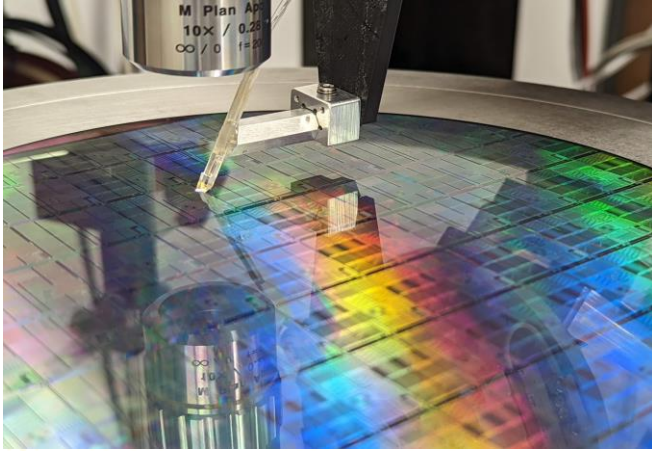
Cons: need cleaved facets, large spot-size converters to match mode size to fiber

Pros: grating couplers can be integrated anywhere on PIC, no cleaving needed

Cons: limited wavelength range, polarization dependent, higher coupling loss

Wafer-Level Edge Coupling

Wafer-level edge coupling using OPAL-EC



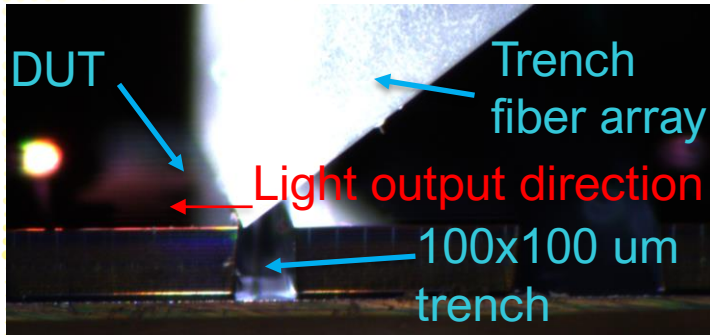
No need to separate wafer into dies for testing

Safe time, cost and effort to manually pick, place and test dies individually

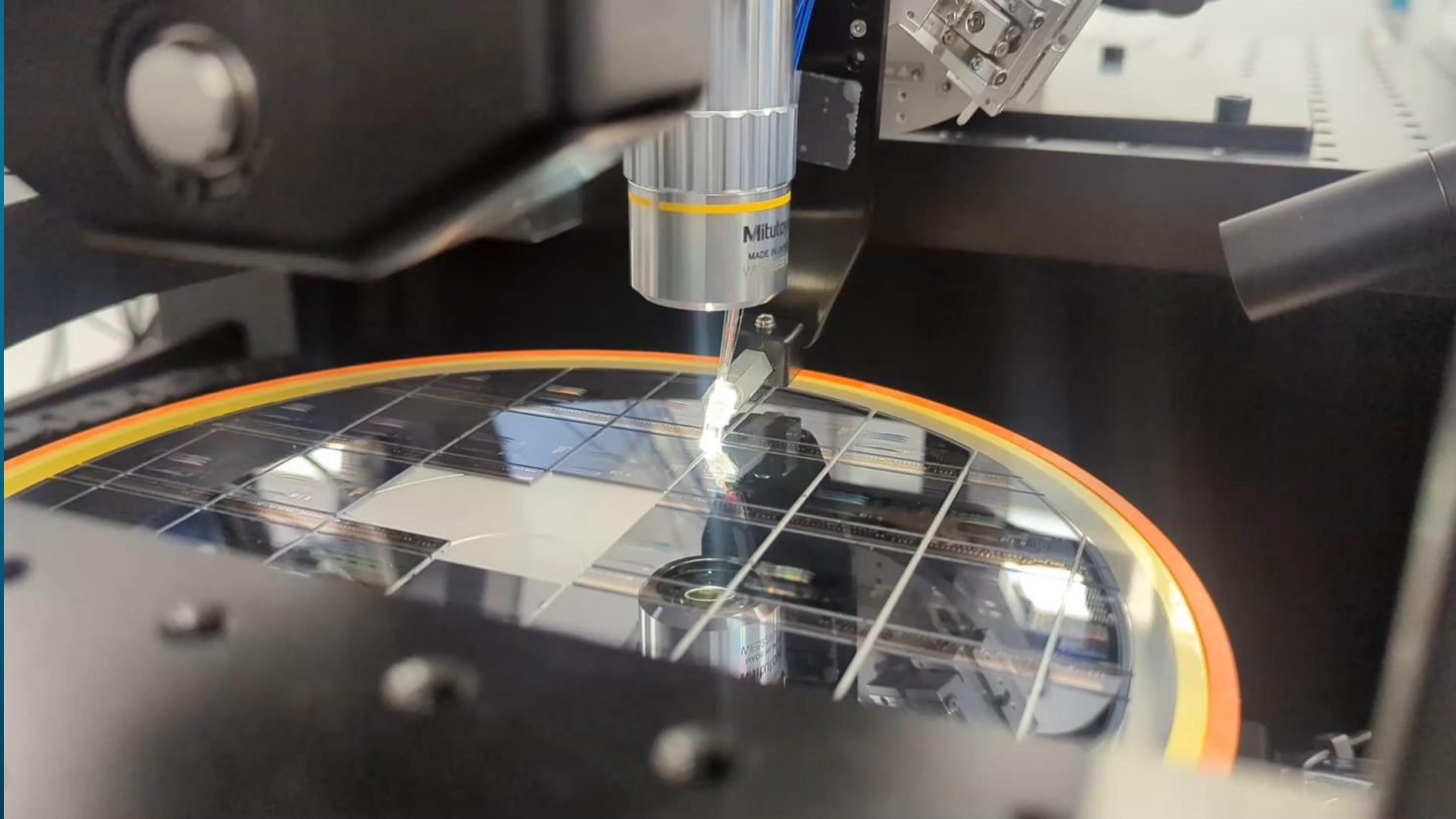
Leverage best coupling performance of edge coupling

High accuracy and repeatability key to assure no collisions during wafer test

Multi-port edge coupling for parallel testing



Running Automated Test Plans

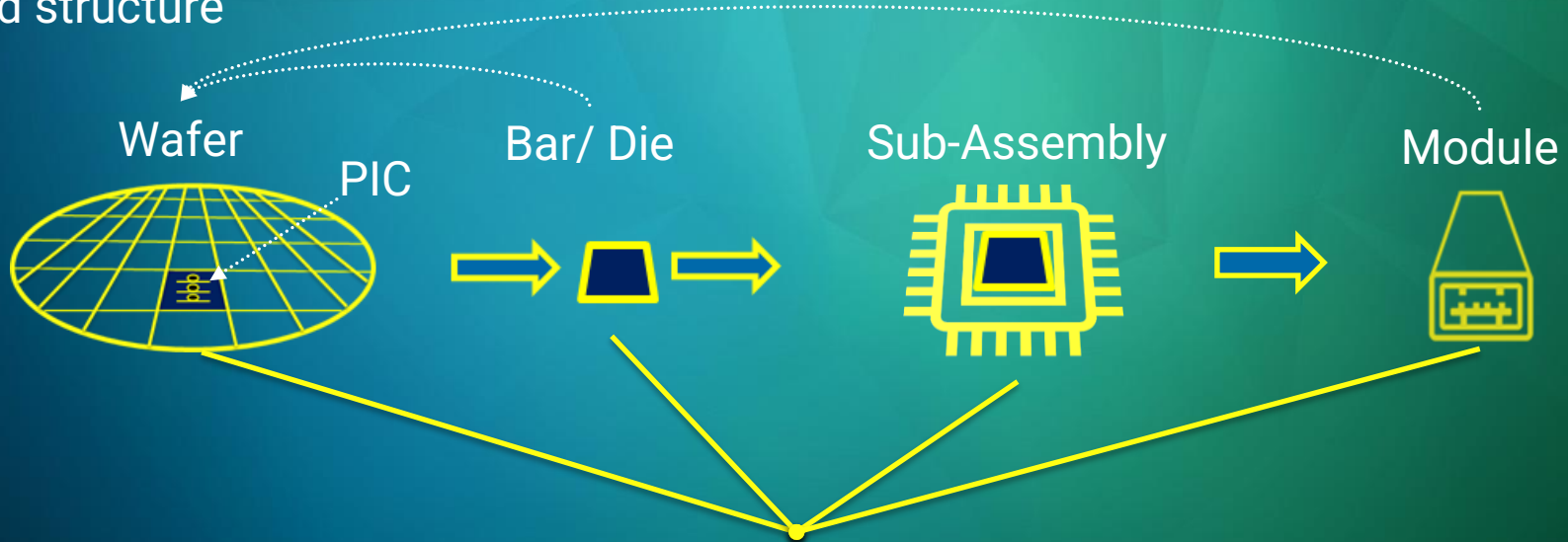


Link: <https://cdn.jwplayer.com/previews/n0j3TUSV-xpehj8NL>

Life of PIC - from wafer to module

Reusable and connected test environment from wafer to module

Flexible definition of test/analysis scripts, wafer/reticle/die parameters, locations and structure



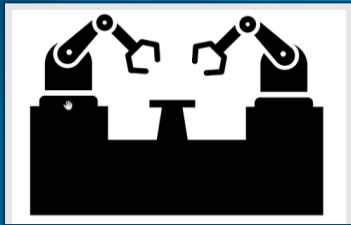
De-coupled concepts and responsibilities (users, apps):
Everything links together

Machine learning to Cut Test Time and Costs

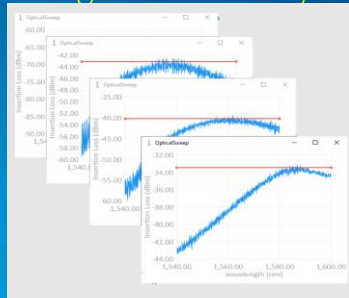
Data-driven live decision-making flow

Skip predicted bad circuits

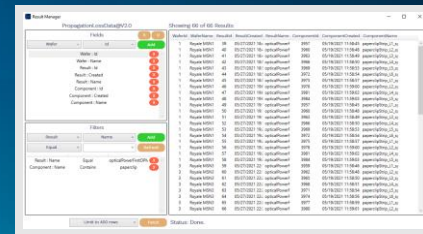
1. Collect test results



2. Extract figures of merit using batched analysis

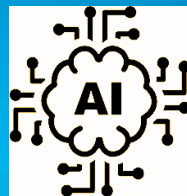
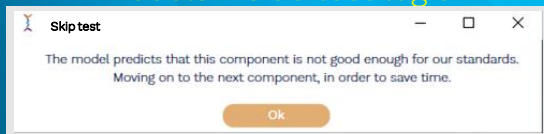


3. Build custom datasets from database

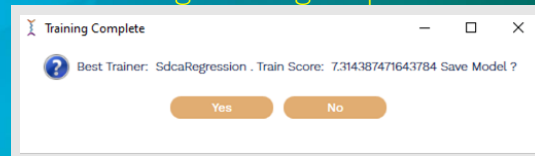


Index	ID	Name	Component Name	Test Name	Component ID	Test ID	Status
1	10000001	Test 1	Component 1	Test 1	10000001	10000001	Pass
2	10000002	Test 2	Component 2	Test 2	10000002	10000002	Fail
3	10000003	Test 3	Component 3	Test 3	10000003	10000003	Pass
4	10000004	Test 4	Component 4	Test 4	10000004	10000004	Fail
5	10000005	Test 5	Component 5	Test 5	10000005	10000005	Pass

5. Consume predictive models inside test logic



4. Train predictive models with machine learning training sequences



Thank you!

Third-party instrumentation

PILOT – Full-Automation Software

STATIONS

Edge & Surface
Wafer & die
PIC testing



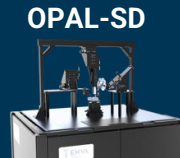
OPAL-EC

Edge & Surface
Multiple & single-die
PIC testing



OPAL-MD

Edge & Surface
single-die
PIC testing



OPAL-SD

LAB-ON-A-RACK – PASSIVE + ACTIVE

Optical test Platform

Light sources, VOA, opt. switch, OSA, power meters

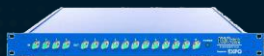


LTB-12



OSICS

Matrix Switch



MXS-9100

Array of VOA



MOA-3800

SPECTRAL – PASSIVE COMPONENT

Swept tunable lasers



T200S



T500S

Passive optical component tester



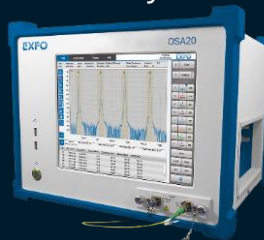
CTP10



CT440

SPECTRAL – ACTIVE COMPONENT

Optical spectrum analyzer



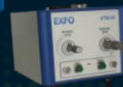
OSA20

Tunable filters



XTA-50

XTM-50



TRAFFIC ANALYSIS

BER tester



BA-4000

Sampling scope



EA-4000

Clock recovery



CD-4000

EXFO